OTPE 47.0

AP

AMENDMENT TRANSMITTAL LETTER					After Final Rejection	
Application I	No.	Filing Dat		Examine		Group Art Unit
10/780,526		February 17, 2004		S. A. Gebrem		2811
		c, Michael Murphy, Richard A. S		Stall, Bryan S.		
She	lton, Linlin Liu,	and Alex D. C	eruzzi		VEL	OX 3.0-001
Invention: LOW DOPED LAYER FOR NITRIDE-BASED SEMICONDUCTOR DEVICE						
TO THE COMMISSIONER FOR PATENTS						
Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.						
			S AS AMEN			
	Claims		S AS AWEN	DED		
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate		
Total Claims	38	- 76 =		×		
Independent	3	- 6 =		×		
Claims						
Multiple Dependent Claims (check if applicable)						
Other fee (please specify):						
TOTAL ADDITI	ONAL FEE FO	OR THIS AME	NDMENT:			0.00
x Large Entity Small Entity						
x No additional fee is required for this amendment.						
Please charge Deposit Account No in the amount of A duplicate copy of this sheet is enclosed.						
A check in the amount of \$ to cover the filing fee is enclosed.						
The Commissioner is hereby authorized to charge and credit Deposit Account No. 12-1095 as described below. A duplicate copy of this sheet is enclosed.						
x Credit any overpayment.						
x Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.						
1	9	Rus				
Laure		. Muss		Dated:	August	2, 2006
Lawrence E. Ru Attorney Reg. N						
LERNER, DAVID, LITTENBERG, KRUMHOLZ & MENTLIK, LLP 600 South Avenue West Westfield, New Jersey 07090 (908) 518-6309						
						
I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as First Class Mail, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.						
Dated: August 2, 2006 Signature: Lustawrence E. Russ)						

AUG 0 7 7006 W

hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as First Class Mail, in an envelope addressed to: MS AF, Commissioner for Patents, P.O. Box 450, Alexandria, VA 22313 450.

Dated: August 2, 2006

(Lawrence E. Russ)

EXPEDITED PROCEDURE

Group Art Unit: 2811

Docket No.: VELOX 3.0-001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Pophristic et al.

Application No.: 10/780,526

: Group Art Unit: 2811

Filed: February 17, 2004

: Examiner: S. A.

: Gebremariam

:

For: LOW DOPED LAYER FOR NITRIDE-BASED SEMICONDUCTOR DEVICE

AMENDMENT UNDER 37 CFR 1.116

MS AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated May 3, 2006, finally rejecting claims 1-17, 19-36, and 71-73, please amend the above-identified U.S. patent application as follows: